



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Avi Tepman et al.

Serial No.: 10/074,854

Filed: February 11, 2002

Title: Variable Flow Deposition Apparatus
And Method in Semiconductor
Substrate Processing.

§ Group Art Unit: 2823

§

§

§

§ Examiner: W. David Coleman

§

§

§

§

§ Attorney Docket No.: AM5018/ISM

Date: July 15, 2003

RESPONSE TO RESTRICTION REQUIREMENT UNDER 37 C.F.R. 1.143

Hon. Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir:

The present communication is in response to the Office Action dated June 27, 2003, outlining the Examiner's restriction requirement between Method Claims 1-27 and Apparatus Claims 28-51.

In response to the Examiner's requirement of election of claims, Applicant's undersigned Attorney hereby elects Method Claims 1-27 for prosecution, with traverse.

--

EXPRESS MAIL UNDER 37 CFR 1.10

I hereby declare that this paper is being deposited with the U.S. Postal Service on the date shown below as Express Mail, Mailer No. EL341110851US addressed to the: Commissioner of Patents and Trademarks, Box :NON-Fee Amendment, P.O. BOX 1450, Alexandria, VA 22312-1450.

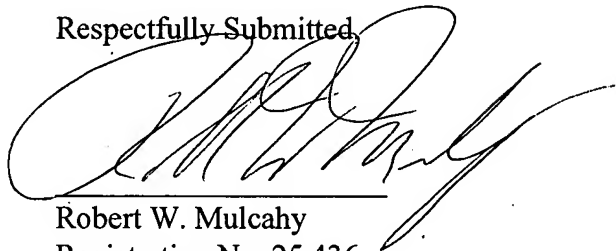
Date

07/15/03


Robert W Mulcahy

Applicant's undersigned attorney invites any direct telephone communication from the Examiner to expedite prosecution of the subject Application.

Respectfully Submitted,

A handwritten signature in black ink, appearing to read 'R. W. Mulcahy', written over a horizontal line.

Robert W. Mulcahy
Registration No. 25,436
Attorney for Applicant
(408)-563-2726

Correspondence Address:
Robert W. Mulcahy, Esq.
Applied Materials, Inc.
2881 Scott Blvd.
Santa Clara, CA 95050